



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Yasuaki TANAKA, et al.

Application Division

Serial Number: 10/091,325

Confirmation No: 7967

Filed: March 6, 2002

METHOD AND DEVICE FOR EXPOSURE CONTROL, METHOD AND DEVICE

FOR EXPOSURE, AND METHOD OF MANUFACTURE OF SAME

REQUEST FOR CORRECTED FILING RECEIPT

Mail Stop: Missing Parts Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Customer No.:38834 Atty. Docket No. 991186A

October 12, 2004

Sir:

For:

Please supply the undersigned attorney with a corrected filing receipt for the above-identified application. The undersigned also respectfully requests that the Patent and Trademark Office records be amended to reflect the correction.

In reviewing the Official Filing Receipt, we noted an error in the Power of Attorney and an omission in the First Inventor. The Power of Attorney should read -- The patent practitioners associated with Customer Number 38834--and the First Inventor should read -- Yasuaki Tanaka Tokyo, JAPAN--. A copy of the Patent Application Information Retrieval and the Declaration are enclosed which indicates the correct information. We are enclosing a copy of the filing receipt with the corrections highlighted.

In the event that any fees are required in connection with this paper, please charge our Deposit Account No. <u>50-2866</u>.

Respectfully submitted,

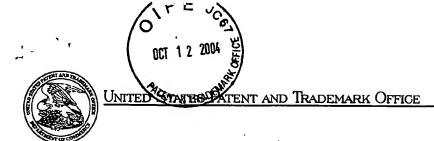
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Steffien G. Adrian Attorney for Applicants Reg. No. 32,878

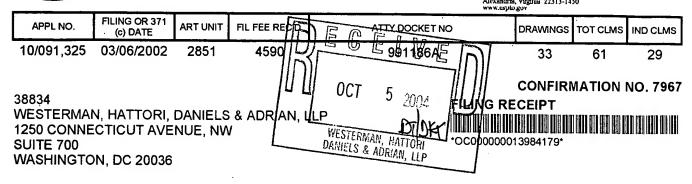
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Enclosures: Official Filing Receipt; Patent Application Information Retrieval; Declaration



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Date Mailed: 10/04/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s) Yasuaki Tanaka, Tokup, JAPAN Please Michio Noboru, Tokyo, JAPAN;

Assignment For Published Patent Application

Nikon Corporation, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 23850.

Domestic Priority data as claimed by applicant

This application is a CON of 09/421,331 10/18/1999 ABN which is a CON of PCT/JP98/01777 04/17/1998

Foreign Applications

JAPAN 116255-1997 04/18/1997 JAPAN 109748/1997 04/25/1997 JAPAN 124527/1997 05/14/1997

If Required, Foreign Filing License Granted: 04/11/2002

The number of your priority application, to be used for filing abroad under the Paris Convention is, US10/091,325

Projected Publication Date: To Be Determined - pending completion of Corrected Papers

Non-Publication Request: No

Early Publication Request: No

Title

Method and device for exposure control, method and device for exposure, and method of manufacture of device

Preliminary Class

355

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Search results as of: 10-7-2004::14:30

| Search results for application number:10/091,325 | | | | | |
|--|---|----------------------------------|---|--|--|
| Application Number: | 10/091,325 | Customer Number: | 38834 | | |
| Filing or 371(c) Date: | 03-06-2002 | Status: | Application Returned back to Preexam | | |
| Application Type: | Utility | Status Date: | 10-01-2004 | | |
| Examiner Name: | • | Location: | OIPE - REISSUE/ABANDONM PROCESSING, CP2-5B16 | | |
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| | Michio Noboru, Tokyo, (JP) | Issue Date of Patent: | I - | | |
| | Method and device for exposure control, method and device for exposure, and method of manufacture of device | | | | |

Select Search Option

Continuity Data

Search

Foreign Priority
Publication Review

| | File History |
|------------|--|
| Date | Contents Description |
| 10-04-2004 | Corrected Paper |
| 03-06-2002 | Drawing Preliminary Amendment |
| 10-01-2004 | Pre-Exam Office Action Withdrawn |
| 10-01-2004 | Application Return TO OIPE |
| 10-01-2004 | Application Dispatched from OIPE |
| 10-01-2004 | Application Is Now Complete |
| 09-03-2004 | Additional Application Filing Fees |
| 09-03-2004 | Applicant has submitted new drawings to correct Corrected Papers |
| 09-27-2004 | Withdraw Publication/Pre-Exam Abandon |
| 09-14-2004 | Correspondence Address Change |
| 09-03-2004 | Workflow incoming petition IFW |
| 09-03-2004 | Workflow incoming petition IFW |
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| 06-13-2002 | Abandonment During Preexam Processing | |
|------------|---------------------------------------|---|
| 03-28-2002 | IFW Scan & PACR Auto Security Review | |
| 03-19-2002 | IFW Scan & PACR Auto Security Review | |
| 03-06-2002 | Initial Exam Team nn | _ |

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